

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Ryo KUBOTO, et al.

Appln. No.: 09/817,233

Confirmation No.: 8072

Filed: March 27, 2001



Docket No: Q62494

Group Art Unit: 2823

Examiner: Hsien Ming LEE

For: **MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE HAVING DRAM CAPACITORS**

STATEMENT UNDER 37 C.F.R. § 1.97(e)

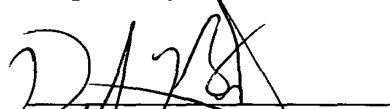
Commissioner for Patents
Washington, D.C. 20231

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,


Howard L. Bernstein
Registration No. 25,665

SUGHRUE MION, PLLC
2100 Pennsylvania Avenue, N.W.
Washington, D.C. 20037-3213
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

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